

EU-Taiwan Workshop

on Transition to 450mm Wafer Processing

AGENDA

Tuesday, March 24, 9:00 – 12:15	
09:00 - 09:30	Registration
09:30 – 09:45	Welcome Remarks Mr. Lou-Chuang Lee, Minister, National Science Council, Taiwan Mr. Guy Ledoux, Head of Office, European Economic and Trade Office, Taiwan Dr. Wen-Hsin Chan, Advisor, DOIT, MOEA, Taiwan (Hosted by Prof. Chee Wee Liu, National Taiwan University, Taiwan)
Session I	Chair: Dr. Fu-Liang Yang, General Director, National Nano Device Laboratories, Taiwan
09:45 – 10:00	"Introduction: The European Commission's Work Programme on 450mm" Mrs. Gisele Roesems, Deputy Head of Unit, DG INFSO, European Commission
10:00 – 10:30	"The Next Generation Manufacturing Era - 450mm Fab" Dr. John Lin, Director, TSMC, Taiwan
10:30 – 11:00	"Collaboration Opportunities for 450mm Development" Mr. Tsuyoshi Abe, Director, Intel Technology & Manufacturing Group, Japan
11:00 - 11:15	Coffee Break
Session II	Chair: Prof. Jenn-Gwo Hwu, National Taiwan University, Taiwan
11:15 – 11:45	"The Role of European Research Institutes in the 450mm Wafer Transition Process"
11:45 – 12:15	Dr. Luc Van den hove, Executive Vice President and COO, IMEC, Belgium "A Win-Win Strategy in 450mm Collaboration Buildup" Dr. John Jahn, Director, Electronics & Information Industry Division, IKE/ITRI, Taiwan



EU-Taiwan Workshop

on Transition to 450mm Wafer Processing

AGENDA

Tuesday, March 24, 12:15 – 16:30	
12:15 - 13:15	Lunch
Session III	Chair: Prof. Horng-Chih Lin, National Chiao Tung University, Taiwan
13:15 – 13:45	"The View of Equipment Suppliers on the 450mm Wafer Transition Process" Mr. Jefferson Chang, General Manager, RECIF Technologies, Taiwan
13:45 – 14:15	"The View of Equipment Suppliers on the 450mm Wafer Transition Process" Mr. Tony Chao, Managing Director, ASML Taiwan
14:15 – 14:45	"450mm FOUP/FOSB Development Status in Taiwan" Dr. Poshin Lee, Technical Manager, Gudeng Precision Industrial, Taiwan
14:45 - 15:00	Coffee Break
Session IV	Chair: Prof. Jeng-Ywan Jeng, National Taiwan University of Science and Technology, Taiwan
15:00 – 15:30	"The Challenge of Metrology in the 450mm Wafer Transition Process" Prof. Lothar Pfitzner, Fraunhofer Gesellschaft, IISB, Germany
15:30 – 16:00	"The European 450mm E&M Initiative" Mr. Bas van Nooten, Director European Cooperative Programs, ASM, Netherlands
16:00 – 16:30	Conclusion Dr. Georg Kelm, Head of Sector, DG INFSO, European Commission Prof. Chee Wee Liu, National Taiwan University, Taiwan